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1742

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Notice of Allowance Mailed: September 20, 2004
Issue Fee Paid: December 13, 2004

Application No.: 09/875,789
Filing Date: June 6, 2001
Applicant: Akira ARAI
Group Art Unit: 1742
Examiner: John P. Sheehan
Title: MAGNETIC POWDER, MANUFACTURING METHOD
OF MAGNETIC POWDER AND BONDED MAGNETS
Attorney Docket: 9319A-000228

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Sir:

Please make the information set forth on the enclosed Form 1449 of record in this file. The listed documents were cited in a search report for a corresponding European patent application. However, Applicant makes no admission that the disclosures in these documents affect the presumption of validity for the claims in this issued patent.

Respectfully submitted,

Dated: May 6, 2005

By: 

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FORM HDP-1449 (Based on Form PTO-1449) PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE CITATION (Use several sheets if necessary) Sheet 1 of 1	ATTORNEY DOCKET No.	SERIAL No.
	9319A-000228	09/875,789
	APPLICANT	
	Akira ARAI	
	FILING DATE	GROUP
June 6, 2001	1742	

U.S. PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date
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FOREIGN PATENT DOCUMENTS						
Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation * Yes No
1.		0 302 395	2/8/1989	EPO		N/A

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)		
Ref. Desig.	Examiner's Initials	
1.		Communication from European Patent Office re: counterpart application.

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Examiner:	Date Considered:
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